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U.S. UTILITY Patent Application

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PATENT NUMBER and
ISSUE DATE

APPL NUM 10006704	FILING DATE 12/10/2001	CLASS 438	SUBCLASS 7-11	GAU 2843	EXAMINER Yan/2-Econ
**APPLICANTS: Trapp Shane; 1705					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A DIV OF 09/752,685 01/03/2001					
<h1>BEST AVAILABLE COPY</h1>					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO M4065.0369/P369-A	
TITLE : Method and composition for plasma etching of a self-aligned contact opening <small>U S DEPT OF COMM/PAT. & TM-PTO-436L(R) 12-94</small>					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs.Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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